

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Yutaka TAKAFUJI et al.

Application No.: 10/668,186

Confirmation No.: 4125

Filed: September 24, 2003

Art Unit: 2813

For: SINGLE-CRYSTAL SILICON SUBSTRATE,  
SOI SUBSTRATE, SEMICONDUCTOR  
DEVICE, DISPLAY DEVICE, AND  
MANUFACTURING METHOD OF  
SEMICONDUCTOR DEVICE

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Examiner: L. M. Menz

**SUPPLEMENTAL RESPONSE**

MS ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

Further in response to the Office Action dated January 29, 2008, please consider the following remarks for the above-identified U.S. patent application as follows:

**Remarks** begin on page 2 of this paper.